



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 18, 2026	
IGI Report Number	LG800612223
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OLD EUROPEAN CUT
Measurements	9.15 - 9.23 X 5.63 MM

GRADING RESULTS

Carat Weight	3.02 CARATS
Color Grade	E
Clarity Grade	VVS 2

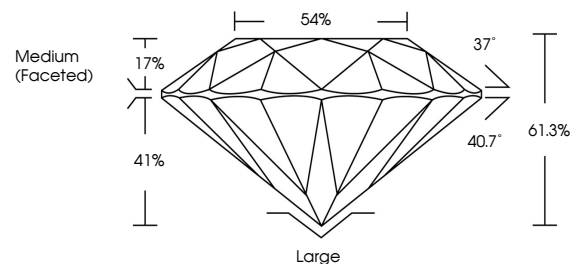
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	

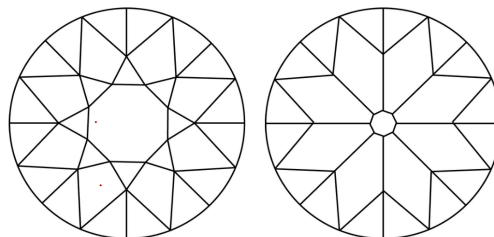
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG800612223
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

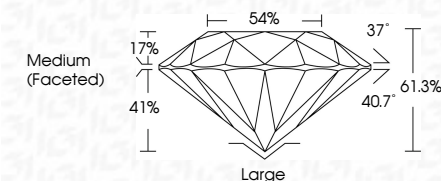
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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DID EUROPEAN CIT

9.15 - 9.23 X 5.63 MM	Carat Weight	3.02 CARATS
	Color Grade	E
	Clarity Grade	VVS 2
	Depth	61.3%
	Table	54%
	Grade	Medium (Faceted)
	Quiet	Large
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE

Comments:
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